:- -.

FIG. 1

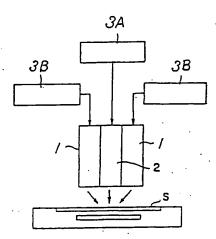


FIG. 2

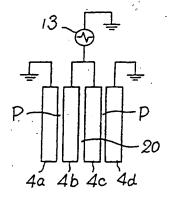


FIG. 3

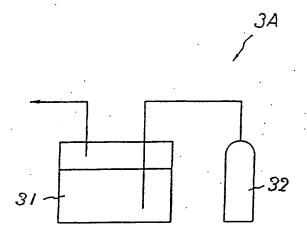


FIG. 4

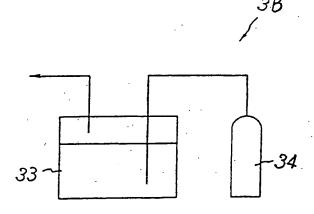


FIG. 5

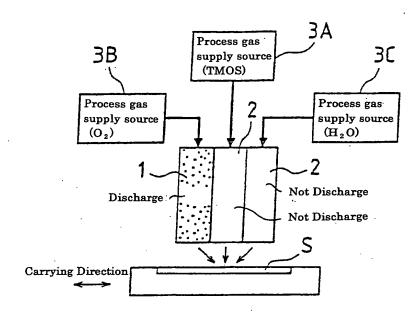


FIG. 6

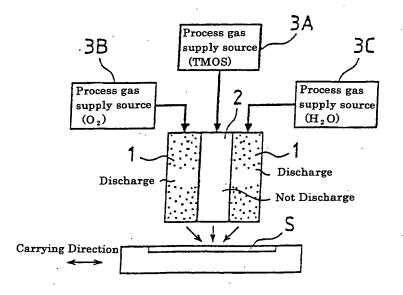


FIG. 7

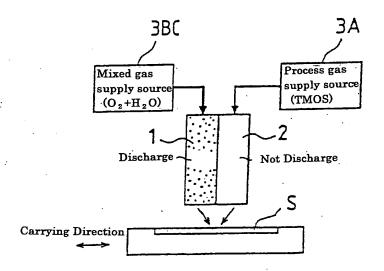


FIG. 8

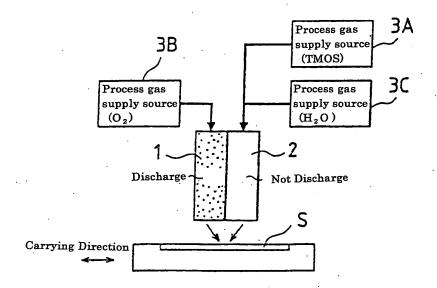


FIG. 9

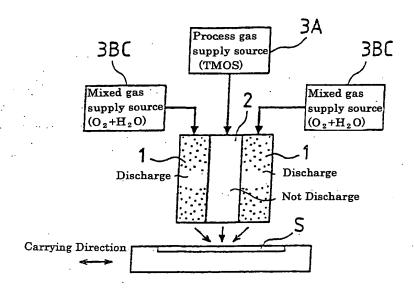


FIG. 10

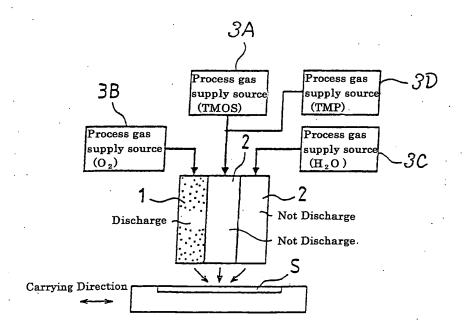


FIG. 11

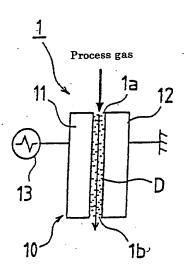
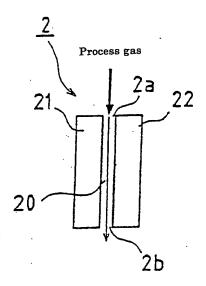


FIG. 12



Yuji EGUCHI, et al. Q85281
OXIDE FILM FORMING METHOD......Alan J. Kasper 202-293-7060
December 14, 2004
7 of 12

10/518013

7 / 1 2

FIG. 13

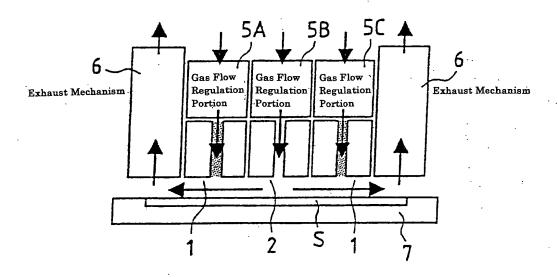
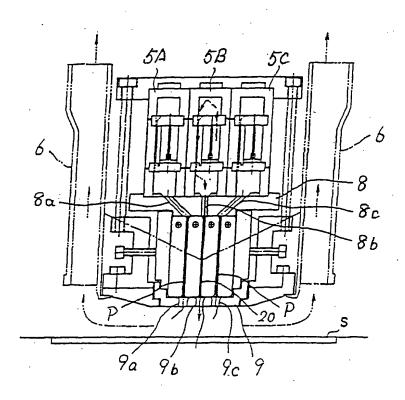


FIG. 14



Yuji EGUCHI, et al.
OXIDE FILM FORMING METHOD...
Alan J. Kasper
December 14, 2004
8 of 12
Q85281
202-293-7060

8/12

FIG. 15

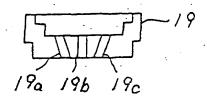


FIG. 16

Evaluation of Coverage Property

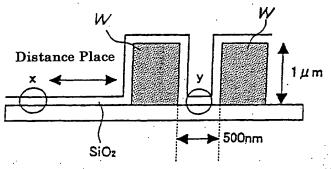


FIG. 17

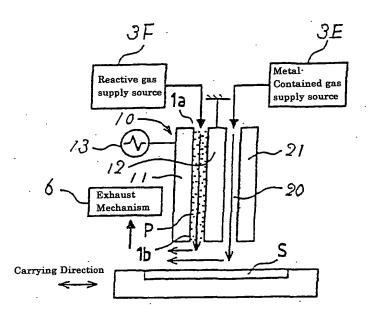
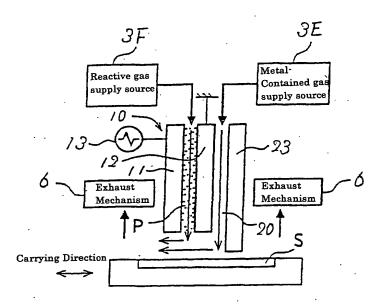


FIG. 18



Yuji EGUCHI, et al. Q85281
OXIDE FILM FORMING METHOD.........
Alan J. Kasper 202-293-7060
December 14, 2004
10 of 12 10/518013

FIG. 19

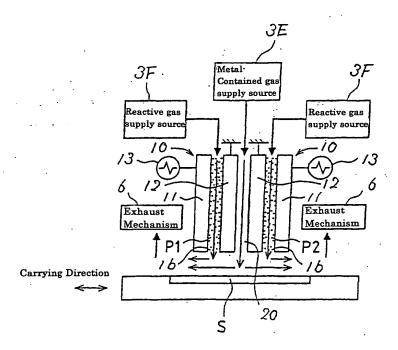
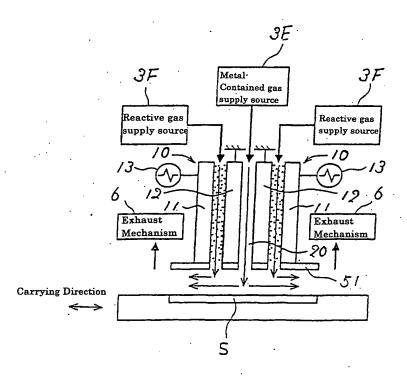


FIG. 20



רעעען אריי

Yuji EGUCHI, et al. Q85281
OXIDE FILM FORMING METHOD.....
Alan J. Kasper 202-293-7060
December 14, 2004
11 of 12 10/518013

FIG. 21

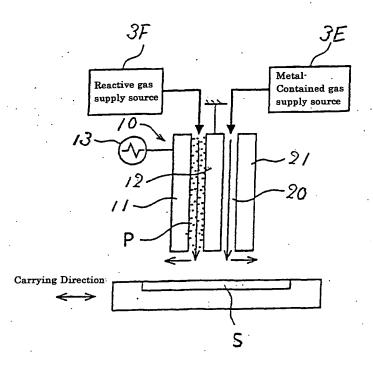
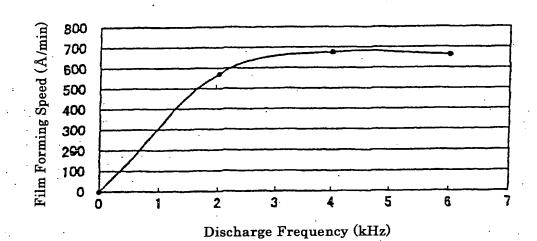


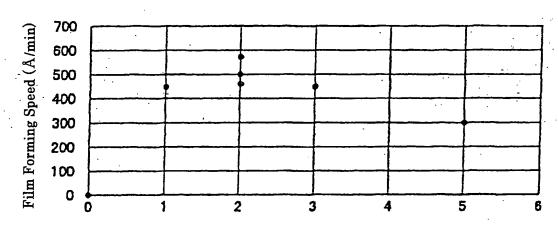
FIG. 22



10/518013

12/12

FIG. 23



Discharge Frequency (kHz)